



#10/D.S.S  
11.7.02  
C. Moore

Inventor: Kie Y. Ahn et al.

Title: A Dielectric Layer Forming Method and Devices Formed Therewith

Assignee: Micron Technology, Inc.

Docket No. MI22-1534

**INFORMATION DISCLOSURE STATEMENT**

References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56.

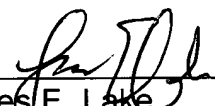
Copies of documents listed on the Form PTO-1449 are enclosed.

No admission is made regarding whether all the submitted references are prior art.

Respectfully submitted,

Dated: 28 Oct 2002

Attorney: \_\_\_\_\_

  
James E. Lake  
Reg. No.: 44,854

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